Rev. 1-10-03 Effective March 1998

DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

() Original () Supplemental () Substitute (X) PCT () DESIGN

As a below named inventor, I hereby declare that: my residence, post office address and citizenship are as stated below next to my name; that I verily believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

Title: MATERIAL FOR FORMING RESIST PROTECTIVE FILM FOR LIQUID IMMERSION LITHOGRAPHY PROCESS, RESIST PROTECTIVE FILM FORMED BY THE MATERIAL, AND METHOD OF FORMING RESIST PATTERNS USING THE MATERIAL

f which is described and claimed in:				•	
the attached specification, or	ial No.	1	and .	with amondments	
rough . or		, filed			
() the specification in International	Application No. PCT/JP2004/012204	, filed <u>Augus</u>	t 25, 2004, and as amend	led on _(if applicable	
hereby state that I have reviewed an any amendment(s) referred to above.	d understand the content of the above	-identified sp	ecification, including the	e claims, as amended	
acknowledge my duty to disclose to t Title 37, Code of Federal Regulation	he Patent and Trademark Office all infons, §1.56.	ormation kno	wn to me to be material to	patentability as defir	
	Title 35, United States Code, §119 (and below and have also identified below on on which priority is claimed:				
COUNTRY	APPLICATION NO.	D	ATE OF FILING	PRIORITY CLAIMED	
Japan	2003-300666	A	august 25, 2003	YES	
Japan	2003-356963	0	ctober 16, 2003	YES	
bject matter of each of the claims of st paragraph of Title 35, United Sta	e 35, United States Code §120 of any this application is not disclosed in the ates Code §112, I acknowledge the duons, §1.56 which occurred between thation:	prior United ty to disclose	States application in the information material to	manner provided by patentability as defin	
APPLICATION SERIAL NO	U.S. FILING DAT	E	STATUS: PATENT ABANDO		
				AND	
				INDS	

And I hereby appoint Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Warren M. Cheek, Jr., Reg. No. 33,367; Nils Pedersen, Reg. No. 33,145; Charles R. Watts, Reg. No. 33,142; Michael S. Huppert, Reg. No. 40,268; Jeffrey R. Filipek, Reg. No. 41,471; and Douglas W. Hahm, Reg. No. 44,142, who together constitute the firm of WENDEROTH, LIND & PONACK, L.L.P., as well as any other attorneys and agents associated with Customer No. 000513, to prosecute this application and to transact all business in the U.S.

Patent and Trademark Office connected therewith.

I hereby authorize the U.S. attorneys and agents named herein to accept and follow instructions from <u>Sakai International Patent Office</u> as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

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	FAMILY NAME	FIRST GIVEN NAME STATE OR COUNTRY	SECOND GIVEN NAME COUNTRY OF CITIZENSHIP

I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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The above application may be more particularly ident	ified as follows:
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Applicant Reference Number PTKA-04109-US (IMN	M-TC5/PCT) Atty Docket No. 2006-0227A

Title of Invention MATERIAL FOR FORMING RESIST PROTECTIVE FILM FOR LIQUID IMMERSION LITHOGRAPHY PROCESS, RESIST PROTECTIVE FILM FORMED BY THE MATERIAL, AND METHOD OF FORMING RESIST PATTERNS USING THE MATERIAL